

**On the early history of atomic layer deposition : most significant works and applications**

Aarik, Jaan; Ahvenniemi, Esko; Akbashev, Andrew R.; **Rauwel, Erwan** 16th International Conference on Atomic Layer Deposition : 24th-27th July 2016, Dublin, Ireland 2016 / [1] p

**Review article : recommended reading list of early publications on atomic layer deposition-outcome of the "Virtual Project on the History of ALD"**

Ahvenniemi, Esko; Akbashev, Andrew R.; Ali, Saima; **Rauwel, Erwan** Journal of vacuum science & technology A : vacuum, surfaces, and films 2017 / p. 010801-1 - 010801-13 <https://doi.org/10.1116/1.4971389> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)